

# Thermal Conductivity Accumulation in Amorphous Materials

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(Dated: August 16, 2013)

## Abstract

We predict the properties of the propagating and non-propagating vibrational modes in amorphous silica (a-SiO<sub>2</sub>) and amorphous silicon (a-Si) and from them, the thermal conductivity accumulation function. The calculations are performed using molecular dynamics simulations, lattice dynamics calculations, and theoretical models. For a-SiO<sub>2</sub>, the propagating modes contribute negligibly to thermal conductivity (6%), in agreement with the thermal conductivity accumulation measured by Regner et al. [Nat. Commun. 4, 1640 (2013)]. For a-Si, propagating modes with mean free paths up to 1  $\mu\text{m}$  contribute 35% of the total thermal conductivity. The predicted contribution to thermal conductivity from non-propagating modes and the total thermal conductivity for a-Si are in agreement with Regner et al.'s measurements. The accumulation in the experimental measurements, however, takes place over a narrower band of mean free paths (100 nm - 1  $\mu\text{m}$ ) than that predicted (10  $\mu\text{m}$  - 1  $\mu\text{m}$ ).

## I. INTRODUCTION

The vibrational modes in disordered solids (e.g., alloys, amorphous materials) can be classified as propagons (propagating and de-localized, i.e., phonon-like), diffusons (non-propagating and de-localized), and locons (non-propagating and localized).<sup>1,2</sup> Diffusons contribute to thermal conductivity by harmonic coupling with other modes due to the disorder. Locons do not contribute significantly to thermal transport in three-dimensional systems.<sup>3</sup>

Experimental measurements, estimates based on experiments, and modeling predictions have demonstrated that propagating modes contribute significantly to the thermal conductivity of amorphous silicon (a-Si)<sup>4–10</sup> and amorphous silicon nitride,<sup>11</sup> but not to that of amorphous silica (a-SiO<sub>2</sub>).<sup>10,12–19</sup> Notably, using broadband frequency domain thermoreflectance, Regner et al. measured how the thermal conductivity of a-SiO<sub>2</sub> and a-Si thin films at a temperature of 300 K change with the penetration depth associated with the heating laser pulse.<sup>10</sup> Following the suggestion of Koh and Cahill,<sup>20</sup> they interpret the measured thermal conductivity at a given penetration depth to be representative of the phonons with mean free paths (MFP) less than that value, allowing for the construction of the thermal conductivity accumulation function.<sup>21–23</sup> For a-SiO<sub>2</sub>, the thermal conductivity of a 1000 nm thick film did not vary for penetration depths between 57 and 960 nm, suggesting that any propagating modes that contribute to thermal conductivity have MFPs below 57 nm. For a-Si, they find that the thermal conductivities of films with thicknesses of 500 and 2000 nm vary by 40% between penetration depths of 44 and 968 nm, suggesting that propagating modes with MFPs in this range contribute significantly to thermal conductivity.

To interpret the results of Regner et al. requires knowledge of the MFPs of the propagating modes and the contribution to thermal conductivity from the non-propagating modes. Experimentally, inelastic neutron scattering can be used to measure phonon lifetimes (and from these, MFPs), but this technique is suited to single-crystal samples.<sup>24</sup> Traditionally, empirical expressions and simple models have been the only means to estimate MFPs in amorphous materials,<sup>12–14,25,26</sup> while the Allen Feldman (AF) theory can be used to model the non-propagating modes.<sup>1,4</sup>

Predicting the vibrational MFPs in an amorphous solid requires the group velocities and lifetimes of the low-frequency propagating modes.<sup>4–8,12,13,16,19</sup> It is typically assumed that the group velocity of these modes is equal to the sound speed.<sup>4–6,12–14,16,25,26</sup> To evaluate the

expressions and models for the low-frequency mode lifetimes requires knowledge of how the lifetimes scale with frequency.<sup>4–8,12,13,16,19,27,28</sup> The scaling for a-SiO<sub>2</sub> has only recently been measured, with evidence of  $\omega^{-2}$ ,  $\omega^{-4}$ , and a second  $\omega^{-2}$  regime as the mode frequency,  $\omega$ , increases from 3.14 to  $6.28 \times 10^{12}$  rads/s.<sup>29–32</sup> For a-Si, the scaling is not well understood,<sup>4–9,27,28</sup> with temperature-dependent<sup>7,27,33</sup> and film thickness-varying measurements<sup>5,7,8,27,34–38</sup> suggesting both  $\omega^{-2}$  and  $\omega^{-4}$  scalings.<sup>4,6</sup>

The objective of this work is to investigate the propagating and non-propagating contributions to the thermal conductivity of a-SiO<sub>2</sub> and a-Si by predicting the MFPs and thermal conductivity accumulation functions for realistic models and comparing the predictions to experimental measurements. The paper is organized as follows. The theoretical formulation and modeling framework are discussed in Section II. The sample preparation for the a-SiO<sub>2</sub> and a-Si bulk models and the computational details are discussed in Section III. In Sections IV A, IV B, and IV C, harmonic lattice dynamics calculations are performed to predict the vibrational density of states, the plane-wave character of the vibrational modes, and the group velocity of the low-frequency propagating modes (i.e., the sound speed). The vibrational mode lifetimes are predicted using the molecular dynamics-based normal mode decomposition (NMD) method in Section IV D. Using the sound speeds and lifetimes, the vibrational mode diffusivities (i.e., the product of the square of the group velocity and the lifetime) are calculated and compared with predictions from the AF theory in Section IV E. Using this comparison, a cutoff frequency between propagating and non-propagating modes is specified. The properties of the propagating and non-propagating modes are then used to predict the total thermal conductivity in Section V A. The thermal conductivity accumulation functions are predicted in Section V B where the results are compared with the experimental results.

## II. THEORETICAL FORMULATION OF VIBRATIONAL THERMAL CONDUCTIVITY

We calculate the total vibrational thermal conductivity,  $k_{vib}$ , of an amorphous solid from

$$k_{vib} = k_{pr} + k_{AF}, \quad (1)$$

where  $k_{pr}$  is the contribution from propagating modes<sup>39–41</sup> and  $k_{AF}$  is the contribution from non-propagating modes predicted by the AF theory.<sup>4</sup> Mode-level properties obtained from molecular dynamics (MD) simulations and lattice dynamics calculations will be used as inputs. Equation (1) has been used in previous studies of amorphous materials,<sup>4–8,12,13,16,19</sup> leading to predictions that while  $k_{pr}$  is a negligible fraction of  $k_{vib}$  for a-SiO<sub>2</sub> (< 10%),<sup>12,13,16,19</sup> it is non-negligible for a-Si (20 – 80%).<sup>4–9</sup>

The propagating contribution is modeled as<sup>4,6</sup>

$$k_{pr} = \frac{1}{V} \int_0^{\omega_{cut}} DOS(\omega) C(\omega) D_{pr}(\omega) d\omega, \quad (2)$$

where  $V$  is the system volume,  $\omega_{cut}$  is the maximum frequency of propagating modes,  $DOS(\omega)$  is the vibrational density of states (DOS),  $C(\omega)$  is the mode specific heat, and  $D_{pr}(\omega)$  is the mode diffusivity. When using mode properties obtained from calculations on finite-sized systems, it is common to write Eq. (2) as a summation over the available modes.<sup>4,6</sup> We choose the integral form because the required use of finite-sized simulation cells limits the lowest frequency modes that can be accessed. An extrapolation must be made to the zero frequency limit that is more easily handled with the integral.<sup>4–8,16,19</sup> Equation (2) is obtained by using the single-mode relaxation time approximation to solve the Boltzmann transport equation for a phonon gas.<sup>41</sup> In the derivation of Eq. (2), the system is assumed to be isotropic (valid for an amorphous material) and have a single polarization, making the mode properties only a function of frequency. The choice of a single polarization (i.e., an averaging of the transverse and longitudinal branches) does not significantly change the results predicted in this work or that of others.<sup>4–8,19</sup> We will evaluate Eq. (2) under the Debye approximation, which assumes isotropic and linear dispersion such that the the DOS is

$$DOS(\omega) = \frac{3\pi\omega^2}{2v_s^3}, \quad (3)$$

where  $v_s$  is an appropriate sound speed.<sup>39</sup>

The specific heat in the classical, harmonic limit is  $k_B$ , where  $k_B$  is the Boltzmann constant.<sup>42</sup> Taking this classical limit allows for a direct comparison between the lattice dynamics-based predictions and those from the classical MD simulations. The harmonic approximation has been found to be valid for systems ranging from Lennard-Jones (LJ) argon,<sup>43</sup> to crystalline Stillinger-Weber silicon and carbon nanotubes<sup>44</sup> at temperatures be-

low half the melting temperature. The full quantum expression for the specific heat is<sup>41</sup>

$$C(\omega) = k_B \left[ \frac{\hbar\omega/2k_B T}{\sinh(\hbar\omega/2k_B T)} \right]^2, \quad (4)$$

where  $\hbar$  is the Planck constant.<sup>39</sup> The quantum specific heat will be used for the non-propagating modes to compare the  $k_{AF}$  predictions to experimental measurements in Sections V A and V B.

The diffusivity of the propagating modes is

$$D_{pr}(\omega) = \frac{1}{3} v_s^2 \tau(\omega), \quad (5)$$

where  $\tau(\omega)$  is the frequency-dependent mode lifetime.<sup>41</sup> An equivalent physical picture in terms of a scattering length is

$$D_{pr}(\omega) = \frac{1}{3} v_s \Lambda(\omega), \quad (6)$$

where  $\Lambda(\omega)$  is the MFP, defined as

$$\Lambda(\omega) = v_s \tau(\omega). \quad (7)$$

The lifetimes will be modeled using

$$\tau(\omega) = B\omega^{-n}. \quad (8)$$

By using a constant sound speed, the lifetime and diffusivity frequency scalings will be the same. For amorphous materials, the scaling exponent  $n$  has been found experimentally and numerically to be between two and four.<sup>4,6-9,29-32,45-63</sup> A value of two corresponds to Umklapp scattering,<sup>64</sup> while a value of four corresponds to Rayleigh scattering from point defects.<sup>65</sup> Combined with Eq. (3), choosing  $n \leq 2$  ensures that the thermal conductivity evaluated from Eq. (2) is finite. Choosing  $n > 2$  causes the thermal conductivity to diverge, which can be fixed using additional anharmonic<sup>4,6</sup> or boundary scattering terms.<sup>5,7,8</sup>

The AF diffuson contribution to thermal conductivity is<sup>4,6</sup>

$$k_{AF} = \frac{1}{V} \sum_{i, \omega_i > \omega_{cut}} C(\omega_i) D_{AF}(\omega_i), \quad (9)$$

where  $\omega_i$  is the frequency of the  $i$ th diffuson mode,  $C(\omega_i)$  is the diffuson specific heat, and  $D_{AF}(\omega_i)$  is the diffuson diffusivity. Equation (9) is written as a sum because there are

enough high-frequency diffusons in the finite-size systems studied here to ensure a converged value.<sup>4,6</sup> The AF diffusivities are calculated from<sup>1</sup>

$$D_{AF}(\omega_i) = \frac{\pi V^2}{\hbar^2 \omega_i^2} \sum_{j \neq i} |S_{ij}|^2 \delta(\omega_i - \omega_j), \quad (10)$$

where  $\delta$  is the Dirac delta function.<sup>66</sup> The heat current operator  $S_{ij}$ , which measures the thermal coupling between vibrational modes  $i$  and  $j$  based on their frequencies and spatial overlap of eigenvectors, can be calculated from harmonic lattice dynamics theory.<sup>1,4,6</sup> For Eq. (10),  $S_{ij}$  is directionally averaged because amorphous materials are isotropic.

### III. CALCULATION DETAILS

#### A. Sample Preparation

The three smallest a-SiO<sub>2</sub> samples are the same as those used in Ref. 67 and contain 288, 576, and 972 atoms at a density of 2350 kg/m<sup>3</sup>. The atomic interactions are modeled using the modified Beest-Kramer-van Santen (BKS) potential<sup>68,69</sup> from Ref. 67, except that the 24-6 LJ potential<sup>70</sup> is changed to a 12-6, which has a negligible effect on the predictions. The LJ potentials use a cutoff of 8.5 Å and the Buckingham potentials use a cutoff of 10 Å. The electrostatic interactions are handled using the Wolf direct summation method with a damping parameter of 0.223 Å<sup>-1</sup> and a cutoff of 12 Å.<sup>71</sup> Larger systems of 2880, 4608, and 34562 atoms were created by tiling the smaller samples, melting at a temperature of 10000 K, and quenching instantaneously to a temperature of 300 K at constant volume. The melt-quench procedure and subsequent MD simulations were performed using the MD package LAMMPS and a time step of 0.905 fs.<sup>72</sup> The resulting a-SiO<sub>2</sub> structure is built from a network of rigidly-bonded SiO<sub>4</sub> tetrahedral sub-units that are weakly bonded via shared oxygen atoms, as shown in Fig. 1 (a). The 34562 atom sample has a supercell side length of 8.05 nm.

For a-Si, we use samples with 216, 1000, 4096, and 100000 atoms generated from the modified Wooten-Winer-Weaire (WWW) algorithm from Ref. 73. The resulting a-Si structure is a rigid, predominantly tetrahedrally-bonded network<sup>73</sup> and is shown in Fig. 1 (b). A larger sample was created from the 100,000 atom sample, which is the largest to our knowledge, by tiling it twice in all directions to create an 800,000 atom sample with a side length of

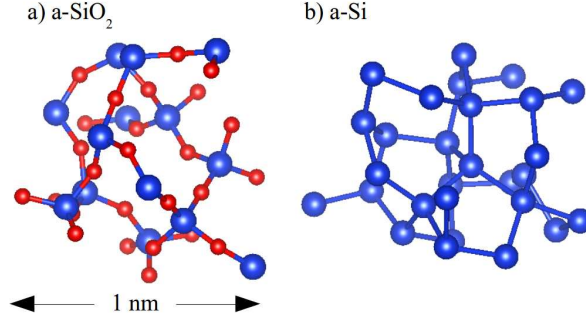


FIG. 1: (a) Small sample of a-SiO<sub>2</sub> created from a melt-quench technique showing the Si-O tetrahedral bond network. Bond lengths range between 1.6 and 1.8 Å. (b) Small sample of a-Si created by the modified WWW algorithm. Bond lengths range between 2.3 and 2.7 Å. Visualizations using the VESTA package.<sup>78</sup>

24.81 nm. All a-Si structures have a density of 2330 kg/m<sup>3</sup>, equivalent to the perfect crystal with a lattice constant of 5.43 Å. The Stillinger-Weber (SW) potential is used to model the atomic interactions.<sup>74</sup> The MD simulations are performed using LAMMPS with a time step of 0.5 fs.

Amorphous materials may have many different atomic configurations with nearly equivalent potential energies, leading to potential metastability during MD simulations.<sup>6,9,75–77</sup> This meta-stability can cause errors when predicting vibrational lifetimes using NMD (see Section IV D). To remove metastability, all a-SiO<sub>2</sub> and a-Si samples were annealed at a temperature of 1100 K for 10 ns.<sup>6,9</sup> The removal of meta-stability is demonstrated by a decrease and plateau of the sample’s potential energy during the annealing.

## B. Simulation Details

Before data collection, all MD simulations are first equilibrated in an  $NVT$  (constant number of atoms, volume, and temperature) ensemble for  $10^6$  time steps at a temperature of 300 K. Data are then collected from simulations in the  $NVE$  (constant number of atoms, volume, and total energy) ensemble for  $2^{21}$  time steps, where the atomic trajectories are sampled every  $2^8$  time steps. Ten MD simulations with different initial conditions are run and the predictions are ensemble-averaged.

The Green-Kubo (GK) method is used to predict a top-down thermal conductivity  $k_{GK}$  [i.e., without using Eq. (1)]<sup>42</sup> using the first-avalanche method to specify the converged value of the integral of the heat current autocorrelation function (Section V A).<sup>79</sup> For system sizes of 4,608 (a-SiO<sub>2</sub>, supercell side length of 4.026 nm) and 4,096 (a-Si, supercell side length of 4.344 nm) atoms, the trajectories from the MD simulations are also used to predict the vibrational mode lifetimes using the NMD method (Section IV D).

For an amorphous supercell, the only allowed wave vector is the Gamma point (i.e.,  $\kappa = 0$ ), where  $\kappa$  is the wavevector and there are  $3N_a$  polarization branches labeled by  $\nu$ , where  $N_a$  is the number of atoms. Calculation of the vibrational modes at the Gamma point requires the eigenvalue solution of a dynamical matrix of size  $(3N_a)^2$  that scales as  $[(3N_a)^2]^3$ , limiting the system sizes that can be considered to 4,608 (a-SiO<sub>2</sub>) and 4,096 (a-Si) atoms. The eigenvalue solution is also required to predict the vibrational DOS (Section IV A) and structure factors (Section IV B), and to perform the NMD calculations (Section IV D) and the AF calculations (Section IV E). The frequencies and eigenvectors were computed using harmonic lattice dynamics calculations with GULP.<sup>80</sup> The calculation of the AF thermal diffusivities [Eq. (10)] is performed using GULP and a Lorentzian broadening of  $14\delta\omega_{avg}$  for a-SiO<sub>2</sub> and  $5\delta\omega_{avg}$  for a-Si, where  $\delta\omega_{avg}$  is the average mode frequency spacing [ $\delta\omega_{avg} = 1.8 \times 10^{10}$  rads/s (a-SiO<sub>2</sub>) and  $1.0 \times 10^{10}$  rads/s (a-Si)].<sup>4,6</sup> Varying the broadening by 10% around these values does not change  $k_{AF}$  within its uncertainty (see Section V A).



## IV. VIBRATIONAL MODE PROPERTIES

### A. Density of States

The vibrational DOS is computed from

$$DOS(\omega) = \sum_i \delta(\omega_i - \omega), \quad (11)$$

where a unit step function of width  $100\delta\omega_{avg}$  is used to broaden  $\delta(\omega_i - \omega)$ . The results for a-SiO<sub>2</sub> and a-Si are plotted in Fig. 2. The DOS for a-Si is similar to that of crystalline silicon,<sup>2,81</sup> with peaks at mid- and high-frequencies. The DOS for a-SiO<sub>2</sub> is constant over most of the frequency-range, with a gap that separates the high-frequency Si-O interactions.<sup>67</sup> There is a clear  $\omega^{-2}$  scaling for both a-Si and a-SiO<sub>2</sub> at the lowest frequencies. The onset of this scaling occurs at a higher frequency for a-Si ( $\sim 1.5 \times 10^{13}$  rads/s) than a-SiO<sub>2</sub> ( $\sim 4.5 \times 10^{12}$  rads/s). This low-frequency scaling is predicted by the Debye model [Eq. (3)] and suggests that these modes may be propagating (i.e., phonon-like).

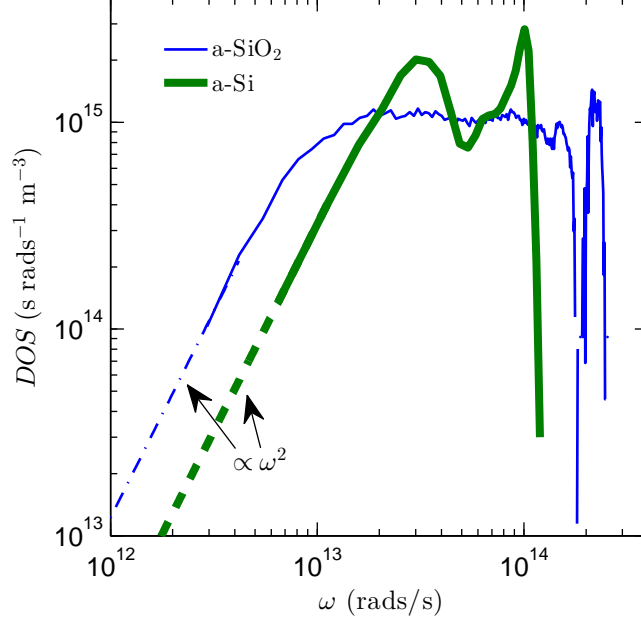


FIG. 2: Vibrational DOS of a-SiO<sub>2</sub> and a-Si plotted on a log-log scale. Both models show an  $\omega^{-2}$  scaling at low frequency. The DOS for a-Si has two peaks similar to the DOS of the crystalline phase.<sup>82</sup> The DOS for a-SiO<sub>2</sub> is flat over most of the spectrum, with a high frequency gap that separates the Si-O interactions.<sup>67</sup>

## B. Structure Factor

Calculating the structure factors of the supercell Gamma modes is a method to test for their propagating (i.e., plane-wave) character at a particular wavevector and polarization. This approach has been previously used to predict effective dispersion curves of disordered and amorphous materials experimentally<sup>19,30,32,46,50,51,83–86</sup> and numerically.<sup>2,4,6,47–49,52,54,57,58,62,87–93</sup> The structure factor at a wavevector  $\boldsymbol{\kappa}$  is defined as<sup>2</sup>

$$S^{L,T}(\boldsymbol{\kappa}) = \sum_{\nu} E^{L,T}(\boldsymbol{\kappa}_{\nu}) \delta(\omega - \omega(\boldsymbol{\kappa}_{\nu}=\mathbf{0})), \quad (12)$$

where the summation is over the Gamma modes,  $E^T$  refers to the transverse polarization and is defined as

$$E^L(\boldsymbol{\kappa}) = \left| \sum_b \hat{\boldsymbol{\kappa}} \cdot e(\boldsymbol{\kappa}_{\nu}=\mathbf{0} \begin{smallmatrix} b \\ a \end{smallmatrix}) \exp[i\boldsymbol{\kappa} \cdot \mathbf{r}_0(\begin{smallmatrix} l=0 \\ b \end{smallmatrix})] \right|^2 \quad (13)$$

and  $E^L$  refers to the longitudinal polarization and is defined as

$$E^T(\boldsymbol{\kappa}) = \left| \sum_b \hat{\boldsymbol{\kappa}} \times e(\boldsymbol{\kappa}=\mathbf{0} \atop \nu \atop \alpha) \exp[i\boldsymbol{\kappa} \cdot \mathbf{r}_0^{(l=0)} \atop b}] \right|^2. \quad (14)$$

In Eqs. (13) and (14), the  $b$  summations are over the atoms in the disordered supercell,  $\mathbf{r}_0^{(l=0)} \atop b$  refers to the equilibrium atomic position of atom  $b$ ,  $l$  labels the unit cells ( $l = 0$  for the supercell),  $\alpha$  labels the Cartesian coordinates, and  $\hat{\boldsymbol{\kappa}}$  is a unit vector. The vibrational mode shape is contained in the  $3N_a$  components of its eigenvector,  $e(\boldsymbol{\kappa}=\mathbf{0} \atop \nu \atop \alpha)$ .<sup>40</sup>

The transverse and longitudinal structure factors are plotted in Figs. 3(a) and 3(b) for a-SiO<sub>2</sub> and a-Si for wavevectors along the [100] direction of the supercells. Because amorphous structures are isotropic, the structure factors are direction-independent. Mode frequencies  $[\omega_0(\boldsymbol{\kappa})]$  and linewidths  $[\Gamma(\boldsymbol{\kappa})]$  can be predicted by fitting each structure factor peak to a Lorentzian function of the form

$$S^{L,T}(\omega) = \frac{C_0(\boldsymbol{\kappa})}{[\omega_0(\boldsymbol{\kappa}) - \omega]^2 + \Gamma^2(\boldsymbol{\kappa})}, \quad (15)$$

where  $C_0(\boldsymbol{\kappa})$  is a constant related to the DOS.<sup>91</sup> A dispersion relation is identified by plotting the  $\omega_0(\boldsymbol{\kappa})$  values in the middle panels of Figs. 3(a) and 3(b), where the error bars indicate the linewidths. For a-Si, Lorentzian fits to the structure factor peaks have coefficients of determination<sup>94</sup> greater than 0.8 for  $|\boldsymbol{\kappa}|/\kappa_{max} \leq 0.75$  and less than 0.7 for  $|\boldsymbol{\kappa}|/\kappa_{max} > 0.75$ , where  $\kappa_{max} = 2\pi/a$  and  $a$  is the lattice constant of crystalline silicon (5.43 Å).<sup>74</sup> For a-SiO<sub>2</sub>, the coefficients of determination are greater than 0.8 for  $|\boldsymbol{\kappa}|/\kappa_{max} \leq 0.2$  and less than 0.7 for larger wavevectors, where the structure factors peaks are less than an order of magnitude larger than the background. To evaluate  $\kappa_{max}$  for a-SiO<sub>2</sub>, we use a lattice constant of 4.8 Å, which corresponds to the  $a$ -direction of quartz.<sup>95</sup>

For a-Si, the extracted dispersion is nearly linear at small wavevectors with a slight decrease in slope at the largest values.<sup>4,6</sup> For a-SiO<sub>2</sub>, the dispersion is concave-down for the smallest wavevectors considered, transitioning to a strong concave-up dispersion at intermediate wavevectors. For the intermediate wavevectors, the longitudinal dispersion for a-SiO<sub>2</sub> is well-described by the so-called “dispersion law for diffusons,” where  $\omega \propto \kappa^2$ .<sup>91</sup> This large concave-up dispersion has been observed in experimental measurements and numerical models of amorphous materials<sup>19,47,52,54,84</sup> including a-SiO<sub>2</sub>.<sup>19,47,52,84</sup> We note that at frequencies lower than 10<sup>12</sup> rads/s, experimental measurements of a-SiO<sub>2</sub> recover a linear

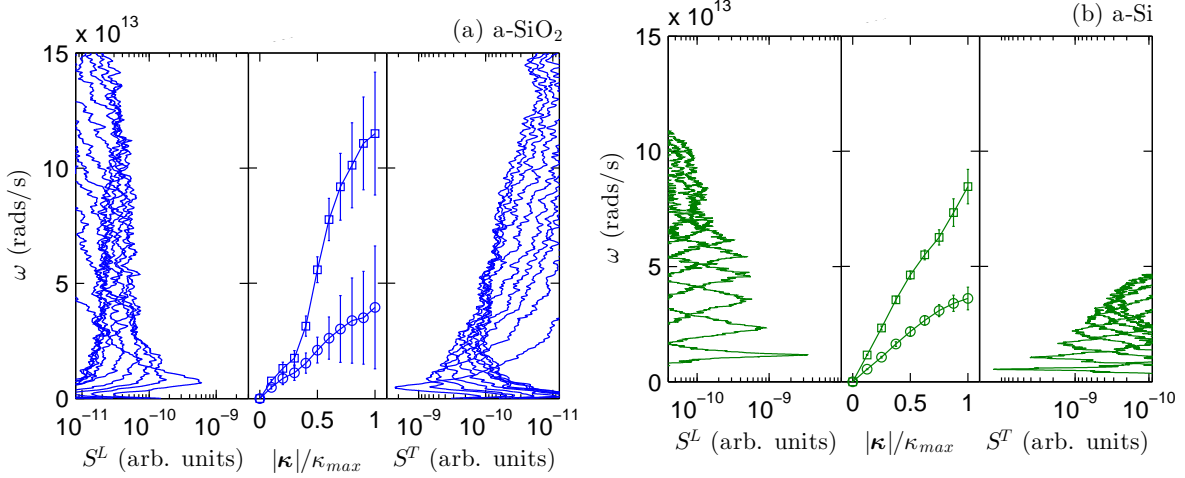


FIG. 3: Longitudinal (left panel) and transverse (right panel) structure factors [Eq. (12)] for (a) a-SiO<sub>2</sub> and (b) a-Si. The wavevectors are normalized by  $\kappa_{max} = 2\pi/a$ , where  $a$  is 4.8 (a-SiO<sub>2</sub>) and 5.43 (a-Si) Å, based on the lattice constants of the crystalline phases.<sup>74,95</sup>

dispersion.<sup>19,30,32,51,84</sup> This frequency range is not accessible with the models studied in this work.

The atomic structures of a-SiO<sub>2</sub> and a-Si play an important role in determining the differences in the low-frequency mode properties. The weakly-bonded network of tetrahedra in a-SiO<sub>2</sub><sup>67–70</sup> results in a Debye scaling of the DOS that occurs at a lower frequency than in a-Si (Fig. 2), which is a network of strongly-bonded tetrahedra.<sup>2,73,74,87</sup> The lower-frequency onset of the Debye-scaling of the DOS for a-SiO<sub>2</sub> leads to the strong non-linear dispersion seen in Fig. 3(a). The behavior of the DOS and structure factors demonstrate a clear difference in the properties of the low-frequency modes for our models of a-SiO<sub>2</sub> and a-Si, which is investigated in the following sections.

### C. Sound Speed

For a disordered solid, except for the transverse and longitudinal sound speeds, there is not an accepted method to predict the group velocity of individual vibrational modes. While the structure factor gives the frequency spectrum needed to construct a propagating state with pure wavevector  $\kappa$ , the individual mode spectra  $E^T(\nu)$  and  $E^L(\nu)$  predict the plane-wave character of each mode.<sup>2,87</sup> It is not generally possible to assign a unique wavevector to individual modes, even at low frequency,<sup>2,87</sup> which makes predicting their group velocities challenging. While attempts have been made to predict individual mode group velocities,<sup>9,81,96–99</sup> there is no theoretical basis for the proposed methods.

We now use the DOS and structure factors predicted in Sections IV A and IV B to predict the group velocities of the low-frequency modes for a-SiO<sub>2</sub> and a-Si (i.e., the sound speeds). By fitting the DOS from Fig. 2 to Eq. (3), a sound speed is obtained and is reported in Table I. Because the DOS is a mixture of transverse and longitudinal modes, only a single sound speed can be predicted. Both longitudinal and transverse sound speeds can be predicted from the structure factor peaks by forward differencing the dispersion relation as

$$v_s = \frac{\omega_0(\kappa_{min})}{\kappa_{min}}, \quad (16)$$

where  $\kappa_{min}$  is  $0.1\kappa_{max}$  for a-SiO<sub>2</sub> and  $0.125\kappa_{max}$  for a-Si. The results are provided in Table I.

The transverse and longitudinal sound speeds of a material can also be predicted from the material's bulk ( $G$ ) and shear ( $K$ ) moduli from<sup>80</sup>

$$v_{s,T} = \left(\frac{G}{\rho}\right)^{1/2} \quad (17)$$

and

$$v_{s,L} = \left[\frac{4G + 3K}{3\rho}\right]^{1/2}. \quad (18)$$

Using the bulk and shear moduli defined in terms of the elastic constants according to the Voigt convention,<sup>80</sup> the corresponding sound speeds are reported in Table I.

The longitudinal and transverse sound speeds for a-SiO<sub>2</sub> predicted using the moduli are 10-20% lower than predictions made using a linear fit to the peaks of the current correlation function for a model with 8016 atoms using the BKS potential [3568 m/s (transverse) and 5937 m/s (longitudinal)].<sup>52</sup> The smaller values predicted by the structure factors and DOS

result from the concave-down dispersion seen at low wavevector (i.e., we are not able to reach the linear portion of the dispersion curve).<sup>52</sup> Experimental measurements of the sound speeds of a-SiO<sub>2</sub> using Brillouin light and inelastic x-ray scattering range between 3800 to 4000 m/s (transverse) and 6000 to 6400 m/s (longitudinal).<sup>46,51,84,100,101</sup> Differences between our predictions and experimental measurements may be related to limitations of the BKS potential.

The effect of the concave-down dispersion is less pronounced for a-Si than for a-SiO<sub>2</sub>, where the sound speeds predicted by all three methods are within five percent of each other. Our sound speed predictions for a-Si using all three methods are within 10% of predictions made using the elastic moduli<sup>102,103</sup> and structure factor<sup>54</sup> from models created by the original WWW algorithm.<sup>104</sup> The 4096 atom model created by the modified WWW algorithm<sup>73</sup> predicted a longitudinal sound speed of 7670 m/s from the structure factor,<sup>57</sup> within 5% of our prediction. In an attempt to explain the anomalously high longitudinal sound speed (8300 m/s) and thermal conductivity measurements in Ref. 7, three 1000 atom a-Si models relaxed using a tight-binding electron structure method predicted an average of 4740 m/s (transverse) and 7830 m/s (longitudinal).<sup>7</sup> By annealing our structures to remove metastability, the sound speeds predicted by the elastic moduli are increased, but not by the amount reported in Ref. 7. Experimental transverse sound speeds measurements using Rayleigh wave scattering are 3420 and 4290 m/s for sputtered and ion-bombarded a-Si thin films,<sup>105</sup> which is within 15% of the predictions from our models. It is clear that the experimentally-measured sound speeds for a-Si show a wide range.

The sound speed  $v_{s,DOS}$  will be used for both a-SiO<sub>2</sub> and a-Si for the rest of this work, allowing for the use of a single polarization for the propagating contribution [Eq. (2)]. By comparing the sound speeds in Table I, it is clear that the low-frequency DOS of our models for a-Si and a-SiO<sub>2</sub> are dominated by transverse modes, which is expected due to their degeneracy and lower frequencies compared to the longitudinal modes. The transverse sound speed predicted for our model of a-SiO<sub>2</sub> is 85% of that predicted by the other methods (Table I) and that measured by experiment.<sup>46,51,84,100,101</sup> While using a smaller transverse sound speed leads to an underprediction of the mode diffusivities [Eq. (5)], it leads to an overprediction of the DOS [Eq. (3)]. Holding all other input parameters in Eq. (1) constant, a smaller sound speed leads to a larger  $k_{pr}$  because the DOS scales as  $1/v_s^3$ . We can thus regard our  $k_{pr}$  prediction as an upper bound.

TABLE I: Longitudinal and transverse sound speeds in m/s estimated from the elastic moduli [Eqs. (17) and (18)], structure factors [Eq. (16)], and DOS [Eq. (3)]. The pre-annealed group velocities predicted by the elastic constants are labeled as Moduli\*.

Method	Moduli*	Moduli $S^T, S^L$	DOS
a-SiO <sub>2</sub>			
Transverse	2,541	3,161	2,732
Longitudinal	4,761	5,100	4,779
a-Si			
Transverse	3,670	3,886	3,699
Longitudinal	7,840	8,271	8,047

#### D. Lifetimes

We now predict the lifetimes of all vibrational modes in our models of a-SiO<sub>2</sub> and a-Si using the MD simulation-based NMD method,<sup>9,43,44,99,106–108</sup> which explicitly includes the disorder in the supercell.<sup>9,92,97,98,109</sup> In NMD, the atomic trajectories from an MD simulation are first mapped onto the vibrational mode coordinate time derivatives,<sup>40</sup>

$$\dot{q}(\boldsymbol{\kappa}=\mathbf{0}; t) = \sum_{\alpha, b, l}^{3, n, N} \sqrt{\frac{m_b}{N}} \dot{u}_\alpha(b; t) e^{*}(\boldsymbol{\kappa}=\mathbf{0} \quad b) \exp[i(\mathbf{0} \cdot \mathbf{r}_0(l))]. \quad (19)$$

Here,  $m_b$  is the mass of the  $b_{th}$  atom in the supercell,  $\dot{u}_\alpha$  is the  $\alpha$ -component of the atomic velocity, and  $t$  is time. Because the supercells of a-SiO<sub>2</sub> and a-Si are disordered, the NMD method can only be performed at the Gamma point ( $\boldsymbol{\kappa} = \mathbf{0}$ ). The spectral energy of each vibrational mode,  $\Phi(\nu, \omega)$ , is calculated from

$$\Phi(\nu, \omega) = \lim_{\tau_0 \rightarrow \infty} \frac{1}{2\tau_0} \left| \frac{1}{\sqrt{2\pi}} \int_0^{\tau_0} \dot{q}(\boldsymbol{\kappa}=\mathbf{0}; t) \exp(-i\omega t) dt \right|^2. \quad (20)$$

We choose the frequency-domain representation of the normal mode energy because we find it to be less sensitive to metastability of the amorphous structure than the time-domain representation.

The vibrational mode frequency and lifetime are predicted by fitting each mode's spectral energy to a Lorentzian function,

$$\Phi(\nu, \omega) = \frac{C_0(\nu)}{[\omega_0(\nu) - \omega]^2 + \Gamma^2(\nu)}, \quad (21)$$

where the constant  $C_0(\nu)$  is related to the average energy of each mode. This expression is valid when the linewidth  $\Gamma(\nu) \ll \omega_0(\nu)$ .<sup>44</sup> The mode lifetime is<sup>106,108</sup>

$$\tau(\nu) = \frac{1}{2\Gamma(\nu)}. \quad (22)$$

The NMD-predicted lifetimes are plotted in Figs. 4(a) and 4(b) for a-SiO<sub>2</sub> and a-Si. Also plotted are the timescales extracted from the structure factor linewidths,  $1/[2\Gamma(\kappa)]$  (Section IV B). For a-SiO<sub>2</sub>, the NMD lifetimes are larger than the Ioffe-Regel (IR) limit  $\tau = 2\pi/\omega$ ,<sup>47</sup> and are bounded by this limit at low frequencies. There is no clear evidence for an  $\omega^{-2}$  scaling, which would correspond to propagating modes. At mid-frequencies, the NMD lifetimes are approximately constant and there is a peak near  $2 \times 10^{14}$  rads/s, which corresponds to the peak in the DOS (see Fig. 2). The lifetimes predicted from the structure factor fall below the NMD-predicted lifetimes and the IR limit. These low values result because the structure factor for a-SiO<sub>2</sub> is evaluated for wavevectors where the resulting wavepackets are formed by non-propagating modes.<sup>2,4,6</sup>

For a-Si, the NMD lifetimes show a clear  $\omega^{-2}$  scaling at low frequency. The lifetimes plateau at higher frequencies, over a wider range of frequencies than for a-SiO<sub>2</sub>, with two peaks corresponding to the peaks in the DOS (see Fig. 2). A similar plateau of lifetimes at high frequencies has been reported for disordered lattices<sup>92,109,110</sup> and other studies of a-Si.<sup>9</sup> The transition from the low-frequency scaling to the plateau region occurs near  $10^{13}$  rads/s, which corresponds to where the DOS first peaks in Fig. 2. Similar behavior has been observed for models of disordered lattices.<sup>92</sup> The lifetimes predicted by the structure factors are in good agreement with those predicted by NMD at low frequencies. Similar agreement has been reported in other models of amorphous materials.<sup>6,111–113</sup> The agreement between the NMD-predicted lifetimes and the structure factor timescales for a-Si at low frequencies indicates that these modes are plane-wave-like and that the wavepackets formed by these modes are propagating.<sup>2,4,6</sup>

The NMD-predicted lifetimes for a-Si range from 0.5 to 10 ps and are similar in magnitude to those predicted for previous WWW-generated models of a-Si.<sup>112–115</sup> We note that one



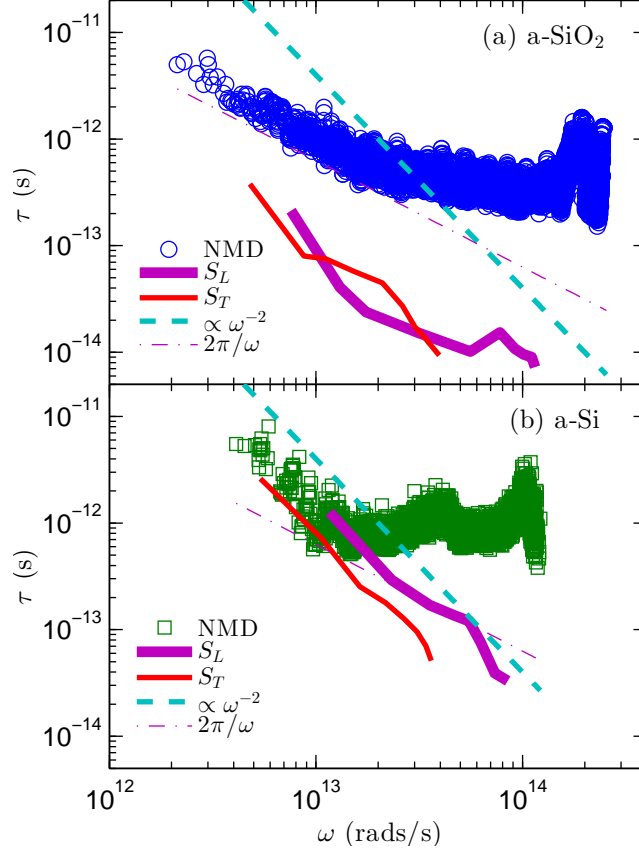


FIG. 4: Vibrational mode lifetimes predicted by NMD [Eq. (22)] and the structure factors [Eq. (15)] for (a) a-SiO<sub>2</sub> and (b) a-Si. The NMD-predicted lifetimes are larger than the IR limit. The lifetimes predicted from the structure factors fall below the IR limit at high-frequency for a-Si and for all frequencies for a-SiO<sub>2</sub>. For a-Si, a clear  $\omega^{-2}$  scaling is observed at low frequencies, while the lifetimes plateau at higher frequencies, over a wider range of frequencies than for a-SiO<sub>2</sub>, with two peaks corresponding to the peaks in the DOS (Fig. 2). The transition from the low-frequency scaling to the plateau region for a-Si occurs near  $10^{13}$  rads/s, which corresponds to where the DOS first peaks in Fig. 2.

previous study of a-Si modeled using the Tersoff potential predicted vibrational lifetimes on the order of 100 ps, an order of magnitude larger than the values reported here and in previous studies.<sup>112–115</sup> It is unclear what the source of this discrepancy is, although in Ref. 9 the NMD analysis was performed in the time domain, where the effects of metastability can be more strongly pronounced. Using the Tersoff potential on the WWW a-Si models in this work, we predict similar lifetimes to those from the SW potential.

## E. Diffusivities

Using the sound speeds predicted from the DOS (Table I), the NMD-predicted lifetimes for a-SiO<sub>2</sub> and a-Si are used to predict the mode diffusivities with Eq. (5). The results are plotted in Figs. 5(a) and 5(b). We note that the sound speed is most appropriate for the lowest-frequency modes, where the DOS scales as  $\omega^2$  (Fig. 2). The AF theory is also used to predict the mode diffusivities and the results are also plotted in Figs. 5(a) and 5(b).

For a-SiO<sub>2</sub>, the mode diffusivities predicted by NMD and AF agree well over the majority of the frequency range. The AF diffusivities at the highest frequencies show a sharp decrease, which is an indication that these modes are localized.<sup>4</sup> The low- and mid-frequency diffusivities are above the high-scatter limit,

$$D_{HS} = \frac{1}{3}v_s a, \quad (23)$$

which assumes that all vibrational modes travel with the sound speed and scatter over a distance of the lattice constant.<sup>14</sup> In evaluating Eq. (23), we use the lattice constant of the crystalline phases (see Section IV B). The low-frequency NMD diffusivities do not show a definitive scaling. Based on the results in Ref. 19, we choose a propagating/non-propagating cutoff frequency of  $4.55 \times 10^{12}$  rads/s, which is at the onset of the Debye scaling of the DOS (Fig. 2). The constant  $B$  in Eq. (8) for  $n = 2$  is then fit to the AF-predicted diffusivities for frequencies below the cutoff by dividing the diffusivities by  $v_{s,DOS}$ . The fit value is  $B = 2.95 \times 10^{13} \text{ s}^{-2}$ .

For a-Si, the mode diffusivities predicted by NMD at low frequencies show a clear  $\omega^{-2}$  scaling. The NMD-predicted diffusivities are larger and show less scatter than those predicted by the AF theory, which is due to the finite-size system and the broadening that is required to evaluate Eq. (10).<sup>4</sup> By using a larger broadening ( $100\delta\omega_{avg}$ ), the scatter in the AF-predicted diffusivities at low frequency can be smoothed, but at the cost of decreasing the diffusivities at intermediate and high frequencies, which affects the predicted diffuson contribution to thermal conductivity (see Section V A). It is possible that a frequency-dependent broadening may be necessary for a-Si and the AF theory, but determining this dependence is not necessary for interpreting our results. For a-Si, the NMD- and AF-predicted diffusivities diverge near a frequency of  $10^{13}$  rads/s. The NMD-predicted diffusivities are relatively constant above this frequency, indicating that the sound speed is no longer an applicable

scaling. The AF diffusivities are larger than the high-scatter limit [Eq. (23)], except for the highest frequency modes, which are localized.<sup>4</sup>

For a-Si, we choose  $\omega_{cut}$  and  $B$  so that Eq. (5) is equal to the average AF-predicted diffusivity at the cutoff frequency. The resulting values are  $\omega_{cut} = 1.16 \times 10^{13}$  rads/s (which is at the onset of the Debye scaling of the DOS, Fig. 2) and  $B = 2.76 \times 10^{14} \text{ s}^{-2}$ . This choice allows Eq. (5) to pass reasonably well through both the AF- and NMD-predicted diffusivities.

While experiments on a-SiO<sub>2</sub> show that there is a cross-over region for the low-frequency lifetime scaling from  $\omega^{-2}$  to  $\omega^{-4}$ ,<sup>29</sup> and back to  $\omega^{-2}$ ,<sup>29-32</sup> our present model is not large enough to investigate the mode properties in this cross-over region. Because experiments are limited for a-Si thin films,<sup>28</sup> we also consider a  $\omega^{-4}$  scaling for Eq. (8). Because this scaling is not clear from the data in Fig. 5(b), we use a cutoff frequency of  $1.52 \times 10^{13}$  rads/s (which is at the onset of the Debye scaling of the DOS, Fig. 2) based on Refs. 4 and 5 and choose  $B = 2.07 \times 10^{40} \text{ s}^{-4}$  so that Eq. (5) is equal to the average AF-predicted diffusivity at the cutoff frequency.

Both a-SiO<sub>2</sub> and a-Si have a region at higher frequencies where the AF-predicted mode diffusivities are relatively constant. This behavior has been reported for model disordered systems such as disordered lattices<sup>91,92,110</sup> and jammed systems.<sup>59,61</sup> While diffusons are non-propagating modes whose MFPs are not well-defined,<sup>4</sup> a diffuson MFP can be calculated from

$$\Lambda_{AF}(\omega_i) = [3D_{AF}(\omega_i)\tau(\omega_i)]^{1/2}, \quad (24)$$

where  $\tau(\omega_i)$  is the NMD-predicted lifetime for that mode. Using this definition,  $\Lambda_{AF}(\omega_i)$  for both a-SiO<sub>2</sub> and a-Si is found to vary between the crystal lattice constant ( $\sim 0.5$  nm) and the supercell size ( $\sim 5$  nm) for modes with frequency above the cutoff. Similar MFPs have been estimated for diffusons in a-Si in previous studies.<sup>4,6</sup> For modes with frequency below the cutoff, the NMD-predicted MFPs from Eq. (7) range up to 16 nm (a-SiO<sub>2</sub>) and 43 nm (a-Si). This result is in contrast to the MFPs estimated in Ref. 9 for a-Si, which ranged up to 500 nm. We believe that the origin of the large MFPs in Ref. 9 is a combination of the predicted lifetimes (see Section IV D) and the method used to estimate the mode group velocities.

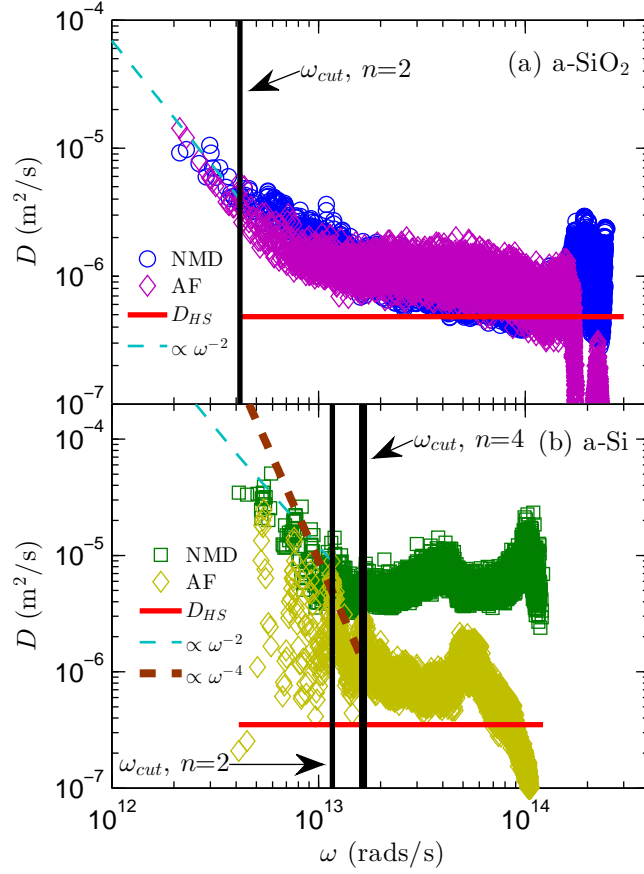


FIG. 5: Vibrational mode diffusivities predicted from NMD [using Eqs. (5) and (22) with the DOS sound speed from Table I] and the AF theory [Eq. (10)]. Also shown are extrapolations based on an  $\omega^{-2}$  scaling with Eqs. (5) and (8) for a-SiO<sub>2</sub> and a-Si, and an additional  $\omega^{-4}$  scaling for a-Si. For both systems, the diffusivities are larger than the high-scatter limit [Eq. (23)] except at high frequencies, where the modes are localized.

## V. THERMAL CONDUCTIVITY

### A. Bulk

To predict the bulk thermal conductivity for our models of a-SiO<sub>2</sub> and a-Si, we use both Eq. (1) and the GK method. The GK method is computationally inexpensive compared to the NMD and AF methods so that larger system sizes can be accessed. The GK-predicted thermal conductivities for a-SiO<sub>2</sub> and a-Si are plotted in Fig. 6 versus the inverse of the system size. For a-SiO<sub>2</sub>, there is no system-size dependence. The bulk thermal conductivity

is estimated to be  $2.1 \pm 0.2$  W/m-K by averaging over all the samples. This prediction is in agreement with the GK predictions in Ref. 67 within the uncertainties, but larger than the MD-based direct-method predictions in Ref. 116. Shenogin et al. predicted the total thermal conductivity of a-SiO<sub>2</sub> using non-equilibrium MD simulations of the same small structures used in this work, finding 2.0 W/m-K for their largest system which was based on a 972 atom model tiled in one direction six times.<sup>117</sup> Our GK-predicted value is larger than experimental measurements, which range between 1.3 and 1.5 W/m-K,<sup>10,14,17,18</sup> which may be due to the classical nature of the MD simulation and/or the suitability of the BKS interatomic potential for modeling thermal transport in a-SiO<sub>2</sub>.<sup>67,116</sup> Quantum statistical effects are considered later in this section.

For a-Si, there is a clear system-size dependence of thermal conductivity. Because the low-frequency DOS has the form of Eq. (3) and the diffusivities scale as  $\omega^{-2}$ , the thermal conductivity will scale as the inverse of the system size. The bulk value can be found by extrapolating to an infinite system size.<sup>44,118,119</sup> The extrapolation is performed using the three largest system sizes,<sup>120</sup> leading to a bulk value of  $2.0 \pm 0.2$  W/m-K, where the uncertainty is estimated from the ensemble averaging for each system size. While it is difficult to create bulk a-Si experimentally,<sup>105</sup> our extrapolated bulk value is in reasonable agreement with experimental values for a wide range of thin film thicknesses (see Fig. 7 in Section V B).

To predict thermal conductivity from Eq. (1), we use the parameters  $B$  and  $\omega_{cut}$  specified in Section IV E assuming an  $\omega^{-2}$  scaling below  $\omega_{cut}$  and the AF-predicted diffusivities. For a-SiO<sub>2</sub>, the propagating, non-propagating, and total thermal conductivities are  $0.10 \pm 0.05$ ,  $1.9 \pm 0.1$ , and  $2.0 \pm 0.1$  W/m-K (see Table II). The uncertainties are estimated by varying  $\omega_{cut}$  and the AF broadening by 10%. The total value agrees with the GK value within the uncertainties. For the propagating contribution using an expression similar to Eq. (2), Baldi et al.<sup>19</sup> estimated 0.1 W/m-K and Love and Anderson<sup>16</sup> estimated 0.03 W/m-K.

By using the  $\omega^{-2}$  diffusivity scaling for a-Si, the propagating, non-propagating, and total thermal conductivities are  $0.6 \pm 0.2$ ,  $1.2 \pm 0.2$ , and  $1.8 \pm 0.2$  W/m-K. This value for total thermal conductivity is in agreement with the GK-predicted bulk value within the uncertainties. Earlier studies using similar models of a-Si found that  $k_{pr}$  is less than half of  $k_{vib}$ ,<sup>4,6</sup> in agreement with our results. A recent study of a-Si modeled using the Tersoff potential found  $k_{pr} \approx k_{AF}$ .<sup>9</sup> Estimates based on experimental measurements have found  $k_{pr}$

to be as low as 20%<sup>5,6</sup> and as high as 80% of  $k_{vib}$ .<sup>7,8</sup>

If an  $\omega^{-4}$  lifetime scaling is assumed for a-Si, the thermal conductivity diverges at low frequency. We bound the thermal conductivity by assuming the sample to be a thin film of thickness  $t_f$  and modify the lifetimes using the Matthiessen rule,<sup>41</sup>

$$\frac{1}{\tau_{eff}} = \frac{1}{\tau_{bulk}} + \frac{2v_s}{t_f}. \quad (25)$$

Using the largest film thickness from the experimental literature ( $80 \mu\text{m}$ )<sup>7</sup> gives a propagating contribution to thermal conductivity of  $3.0 \pm 0.4 \text{ W/m-K}$ . Using the  $\omega^{-2}$  scaling and this film thickness gives a propagating contribution of  $0.6 \text{ W/m-K}$  (i.e., there is no change from the bulk value). While predictions for  $k_{pr}$  for a-Si vary based on the assumed scaling of the low-frequency vibrational lifetimes<sup>4-9</sup> all evidence supports that  $k_{pr}$  is a significant fraction of the total thermal conductivity.<sup>4-10</sup>

In Section II, we approximated the specific heat of the propagating and non-propagating modes by the classical, harmonic-limit value of  $k_B$ . At a temperature of 300 K, the quantum heat capacity [Eq. (4)] at the largest cutoff frequency for either a-SiO<sub>2</sub> or a-Si is  $0.98k_B$ , justifying the use of the classical specific heat in the propagating term in Eq. (2). For the AF contribution, however, the effect of the quantum specific heat is important. At the highest frequencies in a-SiO<sub>2</sub> and a-Si, the specific heat is  $0.073k_B$  and  $0.47k_B$ . Using Eq. (4) in Eq. (9) gives AF thermal conductivities of  $1.4 \pm 0.1$  and  $1.0 \pm 0.1 \text{ W/m-K}$  for a-SiO<sub>2</sub> and a-Si (Table II). This correction brings the estimate of  $k_{vib}$  for a-SiO<sub>2</sub> into good agreement with experimental measurements.<sup>10,14,17,18</sup> For a-Si, the modified  $k_{AF}$  is 20% lower than the classical-limit value.

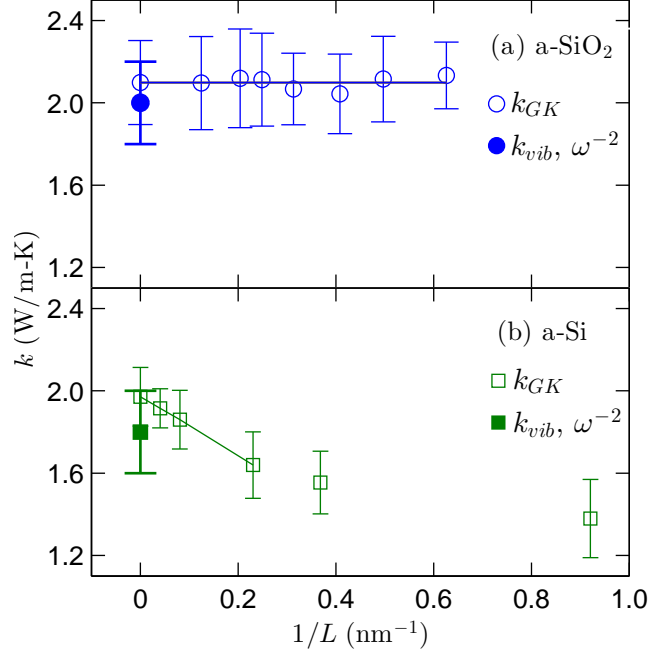


FIG. 6: Thermal conductivities of a-SiO<sub>2</sub> and a-Si predicted using the GK method and Eq. (1). For a-SiO<sub>2</sub>, the GK-predicted thermal conductivity is size-independent, indicating that there is not an important contribution from propagating modes. For a-Si, there is a clear size dependence, indicating the importance of propagating modes.

TABLE II: Thermal conductivities for bulk a-SiO<sub>2</sub> and a-Si predicted by the GK method ( $k_{GK}$ ) and Eqs. (1) ( $k_{vib}$ ), (2) ( $k_{pr}$ ), and (9) ( $k_{AF}$ ). For the non-propagating contribution, classical and quantum specific heats are considered.

Thermal Conductivity (W/m-K)	a-SiO <sub>2</sub>	a-Si
$k_{GK}$	$2.1 \pm 0.2$	$2.0 \pm 0.2$
$k_{vib}$ (classical)	$2.0 \pm 0.1$	$1.8 \pm 0.2$
$k_{pr}$	$0.10 \pm 0.05$	$0.6 \pm 0.2$
$k_{AF}$ (classical)	$1.9 \pm 0.1$	$1.2 \pm 0.1$
$k_{AF}$ (quantum)	$1.4 \pm 0.1$	$1.0 \pm 0.1$
$k_{vib}$ (quantum)	$1.5 \pm 0.1$	$1.6 \pm 0.2$

## B. Accumulation Function

In their broadband frequency domain thermorefectance measurements, Regner et al.,<sup>10</sup> following the suggestion of Koh and Cahill,<sup>20</sup> interpret the measured thermal conductivity at a given penetration depth to be representative of the thermal conductivity accumulation function at a MFP equal to the penetration depth.<sup>21,23</sup> Their results are plotted in Fig. 7(a) for a 1000 nm thick film of a-SiO<sub>2</sub> and in Fig. 7(b) for 500 nm and 2000 nm thick films of a-Si. The vertical coordinate of any point on the accumulation function represents the thermal conductivity that comes from phonons with MFPs less than the horizontal coordinate at that point. Also plotted in Figs. 7(a) and 7(b) are experimental measurements of thin film thermal conductivities. For a-Si, the experimental measurements are grouped broadly by sample preparation technique: (A) chemical vapor deposition<sup>7,8,37</sup> and (B) sputtering.<sup>5,35,36</sup> We note that building the accumulation function using MFPs from Eq. (25) ignores modes that propagate in a direction that is not perpendicular to the cross-plane film direction that may have MFPs larger than the film thickness. Since we consider infinite (a-SiO<sub>2</sub>) and 80  $\mu\text{m}$  (a-Si) film thickness in evaluating Eq. (25), the effect is not important for the range of film thickness and MFPs shown in Figs. 7(a) and 7(b).

Based on the results in Section IV E, we build thermal conductivity accumulation functions for a-SiO<sub>2</sub> and a-Si from

$$k(\Lambda^*) = k_{AF} + \int_{\Lambda_{cut}}^{\Lambda^*} k(\Lambda) d\Lambda, \quad (26)$$

where  $\Lambda_{cut}$  is the MFP at the cut-off frequency,  $\Lambda^*$  is the maximum MFP considered in the thermal conductivity accumulation,  $k(\Lambda)$  is the thermal conductivity as a function of MFP,<sup>23</sup> and the propagating mode MFPs are calculated using lifetimes from Eq. (25). The non-propagating contribution  $k_{AF}$  is evaluated using the quantum specific heat (see Section V A). The results are plotted for a-SiO<sub>2</sub> in Fig. 7(a) using an infinite film thickness and for a-Si in Fig. 7(b) using a film thickness of 80  $\mu\text{m}$ .

The predicted thermal conductivity accumulation function for a-SiO<sub>2</sub> saturates at a MFP of 10 nm, which is on the order of the finite size of our model. This result is in good quantitative agreement with the penetration depth-independent thermal conductivity measurements using broadband FDTR<sup>10</sup> and experimental measurements that show minimal film-thickness dependence.<sup>17,18</sup>



For a-Si, the low-MFP plateau of thermal conductivity in the measurements of Regner et al. is consistent with our predicted  $k_{AF}$ . The propagating contribution to the accumulation is predicted using  $\omega^{-2}$  and  $\omega^{-4}$  lifetime scalings, which have both been inferred from thin film experiments.<sup>4-8,27,38</sup> Predictions for both the  $\omega^{-2}$  and  $\omega^{-4}$  scalings pass reasonably through the experimental measurements, particularly for thin-film measurements in the 50-2000 nm range. The measurements of Regner et al. show sharper accumulations than either the  $\omega^{-2}$  or  $\omega^{-4}$  scalings, particularly for the 2000 nm film. For the  $\omega^{-2}$  scaling, which best matches our model [see Fig. 4(b)], the thermal conductivity accumulation saturates at 1  $\mu\text{m}$ , in good agreement with where the measurements of Regner et al. saturate for their 500 nm thick film. The 2000 nm thick film accumulation shows no sign of saturation.

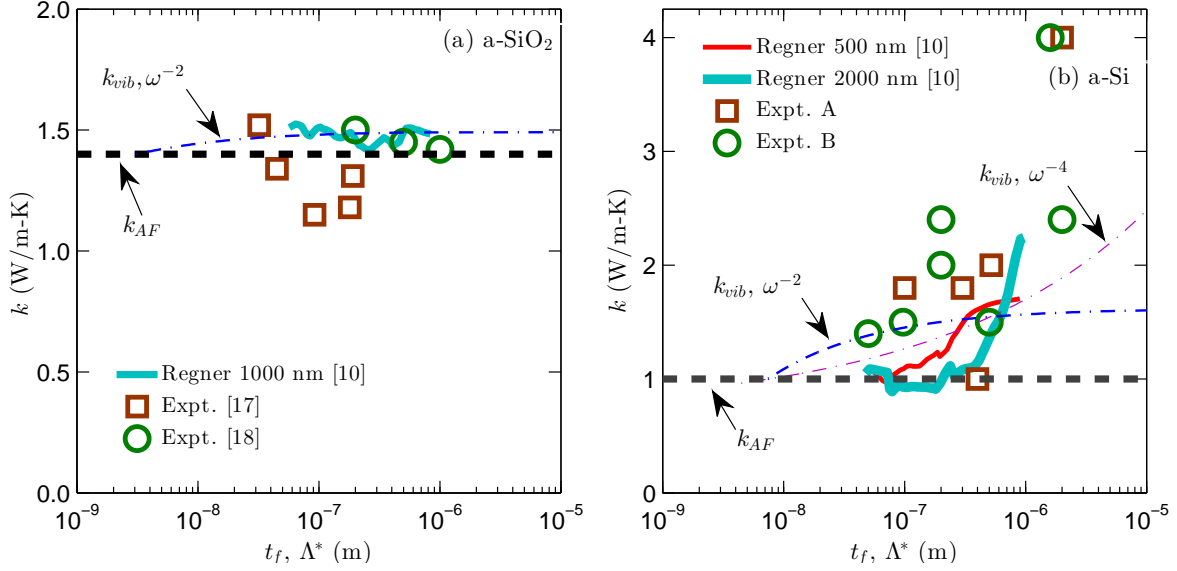


FIG. 7: (a) Predicted thermal conductivity accumulation function [Eq. (26)] for a-SiO<sub>2</sub> compared with experimental broadband frequency domain reflectance measurements by Regner et al.<sup>10</sup> and thin film measurements from Refs. 17 and 18. The predicted thermal conductivity accumulation demonstrates that the propagating contribution is negligible in our model, which is in accord with the experimental measurements. (b) Predicted thermal conductivity accumulation function for a-Si compared with experimental measurements by Regner et al. and thin film measurements fabricated by sputtering (Expt. A)<sup>5,35,36</sup> and chemical vapor deposition (Expt. B)<sup>7,8,34,37</sup> for a range of film thicknesses. The predicted thermal conductivity accumulation demonstrates that the propagating contribution is significant for a-Si. We note that thermal conductivities as high as 6 W/m-K (not plotted) have been measured for a-Si thin films deposited using hot-wire chemical vapor deposition.<sup>8</sup>

## VI. SUMMARY

We investigated the contributions of propagating ( $k_{pr}$ ) and non-propagating ( $k_{AF}$ ) modes to the total vibrational thermal conductivity ( $k_{vib}$ ) of a-SiO<sub>2</sub> and a-Si using the NMD method (Section IV D), AF theory (Section IV E), and the GK method (Section V A). The atomic structures of a-SiO<sub>2</sub> and a-Si play an important role in determining the mode-level properties needed to predict the propagating and non-propagating contributions. The propagating regime ends at a lower frequency for a-SiO<sub>2</sub>, which is evident from the DOS (Fig. 2) and the effective dispersion extracted from the structure factors [Fig. 3(a)]. This smaller maximum

frequency of propagating modes is due, in part, to the weak bonding that exists between the  $\text{SiO}_4$  tetrahedra in a- $\text{SiO}_2$ ,<sup>67–70</sup> while a-Si is formed by a network of strongly-bonded tetrahedra.<sup>2,73,74,87</sup> The structural differences are also apparent in the low-frequency scalings of the mode lifetimes (Fig. 4) which show a clear  $\omega^{-2}$  dependence (i.e., phonon-like) for a-Si, but not for a- $\text{SiO}_2$ . The combined effect of all the mode-level properties results in a significant difference in the propagating and non-propagating contributions to thermal conductivity for a- $\text{SiO}_2$  and a-Si (Table II).

For our model of a- $\text{SiO}_2$ , the contribution from propagating modes is negligible ( $\sim 6\%$ ). Our predictions align with experimental measurements of the film thickness-independence of thermal conductivity<sup>17,18</sup> and penetration depth-independence in the measurements of Regner et al.<sup>10</sup> While the finite size of our model makes it difficult to identify a clear scaling of the low-frequency lifetime scaling, experiments show that both  $\omega^{-2}$  and  $\omega^{-4}$  scalings exist in a- $\text{SiO}_2$ .<sup>29,30,32</sup> In all cases, the propagating contribution to thermal conductivity is negligible.<sup>16–19</sup>

For our model of a-Si, the thermal conductivity has a significant ( $\sim 35\%$ ) contribution from propagating modes that are best described by a lifetime scaling of  $\omega^{-2}$ . Our predicted non-propagating thermal conductivity contribution is in good agreement with the plateau at low-MFP for both films studied by Regner et al. For both films, the thermal conductivities accumulate much faster than our accumulations. The large range of thermal conductivity measurements on a-Si thin films suggest that a comprehensive experimental study using recently developed thermoreflectance techniques<sup>10,20,22,121</sup> on varying film thicknesses and preparation techniques is necessary. It may be particularly helpful to perform the experiments at temperatures less than 10 K, where the propagating contribution dominates for both a- $\text{SiO}_2$  and a-Si and the low-frequency lifetime scaling, which is still under debate, can be better resolved.<sup>4–8,12–16,19,27,30–32,38</sup>

## Acknowledgments

This work was supported by AFOSR award FA95501010098 and by a grant of computer time from the DOD High Performance Computing Modernization Program at the US Army Engineer Research and Development Center. We thank Davide Donadio, Joseph Feldman, Asad Hasan, Jonathan Malen, Craig Maloney, Normand Mousseau, Keith Regner,

and Michael Widom for helpful discussions.

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